RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 1765 PATENT

Customer No. 22,852 Attorney Docket No. 7553.0008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chishio KOSHIMIZU et al.

Group Art Unit: 1765

Application No: 09/665,940

Examiner: L. UMEZ ERONINI

Filed: September 21, 2000

PLASMA PROCESSING APPARATUS AND PLASMA

PROCESSING METHOD

Mail Stop AF

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action dated August 27, 2003, the period for response having been extended to December 27, 2003 by a request for a one month extension of time and fee payment filed concurrently herewith, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper. Remarks follow the amendment sections of this paper.

DUNNERLL

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